

10024471
12/31/01

PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10024471	12/21/2001	117	109	1765	Anderson

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****CONTINUING DATA VERIFIED:**

**** FOREIGN APPLICATIONS VERIFIED:**
JAPAN 2000-401550 12/28/2000

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>
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Foreign priority claimed: ☐ yes ☐ no
35 USC 119 conditions met: ☐ yes ☐ no
Verified and Acknowledged Examiners's initials

ATTORNEY DOCKET NO
01-246

TITLE : Method and apparatus for producing single crystal, substrate for growing single crystal and method for heating single crystal

U.S. DEPT. OF COMM. / PAT. & TM. / PTO-435L/Rev. 12-94

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G.
Assistant Examiner		DRAWING	
		Sheet Drwg.	Fig. Drwg.
ISSUE FEE		Print Fig.	
Amount Due	Date Paid	Application Examiner	
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	
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